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2822



Docket No.: 52352-785 (F0201)

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
George Jonathan KLUTH, et al.	:	Confirmation Number: 9267
	:	
Serial No.: 10/071,207	:	Group Art Unit: 2822
	:	
Filed: February 11, 2002	:	Examiner: GUERRERO, Maria F.
	:	
For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE CONTACTS		

**REQUEST FOR RECONSIDERATION**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

These remarks are being filed in response to the Office Action dated September 25, 2003.

**Remarks** begin on page 2 of this paper.

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